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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Seidl, et al. Attorney Docket: INF-130
Filed: January 28, 2004 Examiner: TBD
Serial No.: 10/765,052 Art Unit: 2812
For: Method of Fabricating an Oxide Collar for a Trench Capacitor

Mail Stop: Amendment
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Respectfully submitted,

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October 14, 2004

Date

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Date of Deposit: October 14, 2004

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Information Disclosure Statement (1 page)
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Copies of (3) cited references
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Certified Copy of DE 103 03 413.7
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Respectfully submitted,

Natalie Swider
Legal Assistant

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PTO/SB/08a (08-03)

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of

1

Complete if Known

Application Number	10/765,052
Filing Date	1/28/2004
First Named Inventor	Seidl, et al.
Art Unit	2812
Examiner Name	TBD
Attorney Docket Number	INF-130

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
	1	US-6,777,303 B2	08-17-2004	Schrems, et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
	2	DE 199 56 078 A1	05-31-2001	Infineon Technologies AG		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	3	KLAUS, J.W., et al., "Atomic Layer Deposition of SiO ₂ Using Catalyzed and Uncatalyzed Self-Limiting Surface Reactions," Surface Review and Letters, Vol. 6, Nos. 3 & 4 (1999) pp. 435-448.	
	4	KLAUS, J.W., et al., "Growth of SiO ₂ at Room Temperature with the Use of Catalyzed Sequential Half-Reactions," Department of Chemistry and Biochemistry, University of Colorado, Boulder, CO (1997).	

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